

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

INOUE et al.

Art Unit: Unassigned

Application No. Unassigned

Examiner: Unassigned

Filed: April 4, 2005

For: METHOD AND APPARATUS FOR  
MANUFACTURING THIN-FILM  
SEMICONDUCTOR

**PRELIMINARY AMENDMENT**

U.S. Patent and Trademark Office  
Randolph Building  
401 Dulany Street, Customer Window, Mail Stop Patent Application  
Alexandria, VA 22314

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.